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PATENT & TRADEMARK OFFICE

MS AMENDMENT
PATENT
3430-0193P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:	Jeong-Rok Kim	Conf.:	6455
Appl. No.:	10/681,140	Group:	2871
Filed:	October 9, 2003	Examiner:	Huyen L. Ngo
For:	Sputter for Deposition of Metal Layer and Fabricating Method of Liquid Crystal Display Device Using the Same		

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 20, 2005

Sir:

In response to the Examiner's Office Action dated June 22, 2005, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

This reply includes

Amended Claim Set; and

Remarks.

09/21/2005 SZEWDIE1 00000016 10681140

01 FC:1201 800.00 OP
02 FC:1202 600.00 OP